



IAW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Leonel R. Arana Et Al.

§ Group Art Unit: 2812

Serial No.: 10/807,836

§

§

§

§

§

§

§

Filed: March 24, 2004

For: Microfabricated Hot Wire Vacuum  
Sensor

Examiner:

Atty. Dkt. No.: ITL.1133US (P19113)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

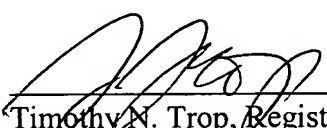
Dear Sir:

Applicant submits the references listed on the attached form PTO 1449 together with any required copies of such references.

This statement is being filed before the receipt of a first Office action on the merits.  
Please apply any charges or credits to Deposit Account 20-1504 (ITL.1133US).

Respectfully submitted,

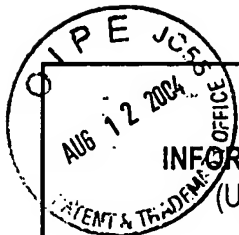
Date: 8/9/04

  
Timothy N. Trop, Registration No. 28,994  
TROP, PRUNER & HU, P.C.  
8554 Katy Freeway, Suite 100  
Houston, Texas 77024  
(713) 468-8880 [Phone]  
(713) 468-8883 [Fax]

Date of Deposit: 8-9-04

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Sherry Tipton

**INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

ATTY DOCKET NO.

ITL.1133US (P19113)

SERIAL NO.

10/807,836

APPLICANT(S):

LEONEL R. ARANA, YUELIN LEE ZOU, AND JOHN HECK

FILING DATE:

March 24, 2004

GROUP ART UNIT:

2812

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.						
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	J.							
	K.							
	L.							
	M.							
	N.							
	O.							
	P.							

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

	Q.	Leonel Arana, "High-Temperature Microfluidic Systems for Thermally-Efficient Fuel Processing", Ph.D. Thesis, Department of Chemical Engineering, MIT, Cambridge, MA, June 2003
	R.	
	S.	
	T.	
	U.	
	V.	
	W.	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.